Discussion for Accelerator Applications: QUASAR Group Away Day, 23rd May 2022

Possible applications for Gas Jet Monitor:

1. Characterize the Electron Beam properties and Quantum Yield of the Photocathodes (In-Site, at the time of deposition)

Possible application for qHAM (Most of these are future applications to explore which are related to accelerator physics also):

- 1. Surface roughness determination of Photocathodes while deposition
- 2. To study the effects of Laser ablation on the Photocathodes (In situ, via coupling the qHAM with Electron Gun).
- 3. It can be used for many day-to-day activities such as spraying painting for quality determination.
- 4. Possibilities with Biological samples in Gel form
- 5. Dielectric structures/Masks in electronics
- 6. Thin film Nb-copper superconducting cavities for determining the uniformity of the surface.
- 7. Optical beam loss monitor degradation studies (In-Situ)

Overall suggestion was to explore the possibilities to make the gas jet monitors compact, easily portable with low maintenance.

<u>3D X-ray imaging</u>: Proof of Concept measurements are already done. Next step is to make a robust and compact device matching with industry standards to provide good quality images.

Possibilities for collaborations/funding:

1. Engagement of companies/Industries: collaboration and contribution from non-academic partners should be mentioned clearly in the proposal and it should have some significant value towards the proposal.

Improving Research activities in the lab:

- 1. Electronic logs and detailed manuals for each experiment, simulation result and equipment should be maintained for proper handover to future users/students. A lot of time is wasted in repeating/rectifying the same error/mistakes.
- 2. Basic training should be provided for simulation softwares, machine learning and programming languages depending upon the requirement.

Possible Machine Learning applications:

1. Automated alignment system for Nozzle-skimmer assembly or optical assemblies.